

MAR 14 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Applicant(s): Paul A. Kohl et al.

Serial No: 09/717,567

Filing Date: November 21, 2000

Title: FABRICATION OF A SEMICONDUCTOR DEVICE WITH AIR GAPS
FOR ULTRA-LOW CAPACITANCE INTERCONNECTIONS

Examiner: James M. Mitchell

Art Unit: 2827

Docket No. PRMSP0217USA

REPLY TO OFFICE ACTION DATED DECEMBER 14, 2004

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following attachments:

Amendments to the Specification
Amendments to the Drawings
Amendments to the Claims
Remarks

Enclosures: ☐ Credit Card Payment Form
☐ Petition for Extension of Time
☐ Information Disclosure Statement

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).